

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of : Customer Number: 20277  
Masayuki HATA, et al. : Confirmation Number: 1109  
Serial No.: 10/766,031 : Group Art Unit: 2811  
Filed: January 29, 2004 : Examiner: Not yet assigned  
For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of each non-English language reference, if any, is discussed in the present specification.

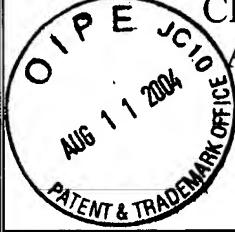
Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT WILL & EMERY LLP

  
Arthur J. Steiner  
Registration No. 26,106

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
202.756.8000 AJS:etp  
Facsimile: 202.756.8087  
**Date: August 11, 2004**

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>57810-085</b>	SERIAL NO. <b>10/766,031</b>	
				APPLICANT <b>Masayuki HATA, et al.</b>		
				FILING DATE <b>January 29, 2004</b>	GROUP <b>2811</b>	
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code <sub>2</sub> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	US					
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<b>FOREIGN PATENT DOCUMENTS</b>						
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation
						Yes
		JP 11-004048	01/06/1999	NICHIA CHEM IND LTD		abstract
		JP 11-214798	08/06/1999	NICHIA CHEM IND LTD		abstract
		JP 2000-044400	02/15/2000	SUMITOMO ELECTRIC AND LTD		abstract
		JP 2000-183459	06/30/2000	OKI ELECTRIC IND CO LTD		abstract
		JP 2001-102307	04/13/2001	SUMITOMO ELECTRIC AND LTD		abstract
		JP 2001-257193	09/21/2001	XEROX CORP		abstract
		JP 2001-267687	09/28/2001	TOSHIBA CORP		abstract
		JP 2002-184707	06/28/2002	SANYO ELECTRIC CO LTD		abstract
		WO 03/038957 A1	05/08/2003	SUMITOMO ELECTRIC AND LTD		abstract
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
<b>EXAMINER</b>			<b>DATE CONSIDERED</b>			

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Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.